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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP01/00330 01/19/2001

** FOREIGN APPLICATIONS *****

JAPAN 2000017479 01/26/2000

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 1	
35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met					
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>GMR</i>			

ADDRESS

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TITLE

Method for producing silicon epitaxial wafer

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